PAGE'3112* RCVD-AT-2128/2005 8:49:21 PM [Eastern Standard Time] * SVR:USPTO-EFXRF-113 * DNIS:8729306 * CSID:14155388380 Of-E0:(ae-mm) MOITARUO * **CENTRAL FAX CENTER**

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Demos et al.

Group Art Unit: 2823

Application No: 10/783,748

Confirmation No: 7358

Examiner: Khiem D. Nguyen

Attorney Docket No:

Filed: February 20, 2004

007034 USA P02/DSM/ELK/JW

Title: CLEAN PROCESS FOR AN

February 28, 2005

ELECTRON BEAM SOURCE

San Francisco, California

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

VIA FACSIMILE (703) 872-9306

Examiner Nguyen:

This communication is in response to the Office Communication mailed on September 29, 2004, and is being filed within five months thereof with a two month extension of time fee.

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Date: February 28, 2005